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				Application Number	10/644957					
	RMATION D			Filing Date	08/21/2003 Gordon BEASE					
STAT	EMENT BY	APPL	ICANT	First Named Inventor						
				Art Unit	1763					
	(Use as many sheets a	в песезвагу)	Examiner Name	MAUREEN G. ARANCIBIA					
Sheet	1	of	1_	Attorney Docket Number	071469-0305396					

NON PATENT LITERATURE DOCUMENTS								
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T,					
WA	1	SWENGER ET AL., ""A Selective Etching Process for Chemically Inert High-k Metal Oxides"," Mat. Res. Suc. Symp. Proc., Materials Research Society, p. 79-84, (2003).						
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